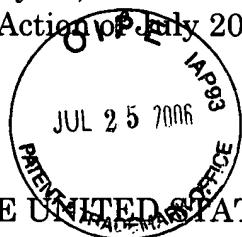


Appl. No. 10/724,570
Amdt. Dated July 20, 2006
Reply to Office Action of July 20, 2006

Attorney Docket No. 81788.0263
Customer No.: 26021



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Akira Tanaka
Serial No: 10/724,570
Confirmation No.: 8635
Filed: November 26, 2003

For: Semiconductor Laser Element, Method
of Fabrication Thereof, and Multi-Wavelength
Monolithic Semiconductor Laser Device

Art Unit: 2828
Examiner: Tod Thomas Van Roy

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	
July 20, 2006 Date of Deposit	
William H. Wright, Reg. No. 36,312 Name	7/20/06 Date
Signature	

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action dated January 20, 2006. The time for responding to the Office Action is extended by three months by the accompanying petition for extension of time. Please amend the above-referenced application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 5 of this paper.

Amendments to the drawings begin on page 14 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks begin on page 15 of this paper.